

## IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Wataru HATTORI

Conf.

Application No. **NEW NATIONAL PHASE**

Group

Filed July 19, 2004

Examiner

METHOD OF MANUFACTURING SURFACE ACOUSTIC WAVE DEVICE AND  
SEMICONDUCTOR DEVICEPRELIMINARY AMENDMENTAssistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 19, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.